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1. Chemical mechanical planarization of microelectronic materials

LCCN 96006198
Type of material Book
Personal name Steigerwald, Joseph M.
Main title Chemical mechanical planarization of microelectronic materials / Joseph M. Steigerwald, Shyam P. Murarka, Ronald J. Gutmann.
Published/Created New York : J. Wiley, c1997.
Description xiii, 324 p. : ill. ; 24 cm.
ISBN 0471138274 (cloth : alk. paper)
Links Contributor biographical information
<http://www.loc.gov/catdir/bios/wiley041/96006198.html>
 Publisher description <http://www.loc.gov/catdir/description/wiley032/96006198.html>
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